

<b>Notice of References Cited</b>	Application/Control No. 10/637,664		Applicant(s)/Patent Under Reexamination IZUMI ET AL.	
	Examiner William M. Brewster		Art Unit 2823	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	K	US-			
	L	US-			
	M	US-			

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	N	10-229180	08-1998	Japan	Kuroiwa Atsushi	H01L 27-14
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**NON-PATENT DOCUMENTS**

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	U	Stanley Wolf Ph.D. in Silicon Processing for the VLSI Era, Volume 2: Process Integration, Lattice Press, 1990, pp. 229-232.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.